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Attorney Docket No. 108298740US

Disclosure No. 02-1418

INFORMATION DISCLOSURE STATEMENT BY APPLICANT Form PTO-1449 (Modified) (Use several sheets if necessary)				COMPLETE IF KNOWN	
				Application Number	
				Confirmation Number	
				Filing Date	
				First Named Inventor	
				Group Art Unit	
Examiner Name					
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U.S. PATENT DOCUMENTS						
Examiner Initials*	Cite No.	U.S. Patent or Application		Name of Patentee or Inventor of Cited Document	Date of Publication or Filing Date of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
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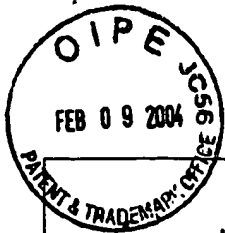
EXAMINER <i>H. Nguyen</i>	DATE CONSIDERED <i>9/2/2004</i>
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				Application Number	
				Confirmation Number	
				Filing Date	October 14, 2003
				First Named Inventor	Jeffrey L. Mackey
				Group Art Unit	
Examiner Name					
Sheet	2	of	2	Attorney Docket No.	108298740US

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		Office	NUMBER	Kind Code (if known)				
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**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**

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COMPLETE IF KNOWN

Application Number	10/684,794
Confirmation Number	4238
Filing Date	October 14, 2003
First Named Inventor	Jeffrey L. Mackey
Group Art Unit	2878
Examiner Name	(To Be Assigned)
Attorney Docket No.	108298740US

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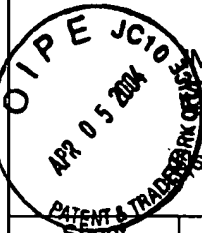
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				Confirmation Number	4238
				Filing Date	October 14, 2003
				First Named Inventor	Jeffrey L. Mackey
				Group Art Unit	2851
Examiner Name	Peter B. Kim				
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